PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/549,251

Applicant Filed

Yuichiro Sasaki et al. September 13, 2005

Title

"BEAM CURRENT MEASURING APPARATUS AND BEAM

CURRENT MEASURING METHOD USING THE SAME"

Confirmation No.

TBD

TC/A.U.

TBD

Examiner

TBD

Customer No.

052054

Docket No.

38771

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT Commissioner for Patents P.O. Box 1450 Alexandria, Va. 22131-1450

Sir/Madam:

In accordance with 37 C.F.R. § 1.98, applicant is submitting herewith Form PTO-1449 listing references for consideration by the Examiner. Also submitted herewith is a legible copy of each reference listed.

If there are any fees resulting from this communication, please charge said fees to our Deposit Account No. 16-0820, Order No. 38771.

Respectfully submitted,

PEARNE & GORDON LLP

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February 20, 2006

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Jeffrey J. Sopko

Name of Attorney for Applicant(s)

February 20, 2006

Date

ature of Attorney

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. 38771			SERIAL NO. 10/549,251	
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FOREIGN PATENT DOCUMENTS

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	L						
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

R	Tanabe, "A Cryogenic Current-Measuring Device with Nano-Ampere Resolution at the Storage Ring TARN II", 09/1998, Pages 455-464
S	Hao et al., "HTS Flux Concentrator For Non-Invasive Sensing Of Charges Particle Beams", 06/2001, Pages 469-470
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Examiner:

J K

Date Considered

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Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.